



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE ("USPTO")

In re the Application of: **Tadashi WATANABE et al.**

Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

MAILSTOP: RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 5, 2008

Sir:

AMENDMENT UNDER 37 C.F.R. §1.114

In response to the Office Action dated September 5, 2008, whose period for response expires December 5, 2008, and concurrent with the filing of a Request for Continued Examination (RCE), kindly amend the above-identified application as set forth below. In view of the same as well as the following remarks, kindly reconsider and further examine the application.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.